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Supertrue for form 1449/PTO SUPPLEMENTAL	Application Number	10/749,096			
	Filing Date	December 30, 2003			
INFORMATION DISCLOSURE	First Named Inventor	Rafael Reif			
STATEMENT BY APPLICANT	Art Unit	3745			
(Use as many sheets as necessary)	Examiner Name	Not Yet Assigned			
	Attorney Docket Number	MIT-136DUS			

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Examiner Initials	Cite No.'	Document Number	Publication Date MM-DD-YYYY	Name of Applicant of	Patentee or Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
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Substitute	for form 1449/PTC		PAI	Application Number	10/749,096	
SUPPLEMENTAL INFORMATION DISCLOSURE				Filing Date	December 30, 2003	
			PPLICANT		Rafael Reif	
				Art Unit .	3745	
	(Use as many sheets as necessary)			Examiner Name	Not Yet Assigned	
Sheet	2	of	2	Attorney Docket Number	MIT-136DUS	

Examiner Initials*	Cite No.	OTHER PRIOR ART-NON PATENT LITERATURE DOCUMENTS Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T ²
	-	PCT/US 03/41407 International Search Report, September 15, 2014.	-
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INFORMATION DISCLOSURE STATEMENT BY APPLICANT

(Use as many sheets as necessary)

of

Complete if Known					
Application Number	10/749,096	_			
Filing Date	December 30, 2003				
First Named Inventor	Rafael Reif				
Art Unit	3745				
Examiner Name	Not Yet Assigned				
Attorney Docket Number	MIT-136DUS	フ			

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Examiner Initials*	Cite No.1	Document Number Number-Kind Code ^{2 (# known)}	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
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		FORE	IGN PATENT DOCU	JMENTS		
Examiner Initials*	Cite No.1	Foreign Patent Document	Publication Date	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages	
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QWO		WO 02/09182 A1	01/31/2002	Christian Val		<u> </u>
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Substitute for form 1449/PTO		Complete if Known				
·				Application Number	10/749,096	
INFO	RMATIO	N DIS	CLOSURE	Filing Date	December 30, 2003	
STATEMENT BY APPLICANT		First Named Inventor	Rafael Reif			
				Art Unit	3745	
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Sheet	2	of	2	Attorney Docket Number	MIT-136DUS	J

· .		OTHER PRIOR ART-NON PATENT LITERATURE DOCUMENTS	
Examiner Initials*	Cite No.1	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T²
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Substitute for form 1449/PTO	Application Number	10/749,096
INFORMATION DISCLOSURE		December 30, 2003
STATEMENT BY APPLICANT	First Named Inventor	Rafael Reif
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(Use as many shoets as necessary)	Examiner Name	Not Yet Assigned
	Attorney Docket Number	MIT-136DUS
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Examiner	0140	Date Considered	1/6/05
Signature	Marketter or not citation is in conformance with MPEP 50	9. Draw line through o	lization if not in conformance and not

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ELECTRONIC INFORMATION DISCLOSURE STATEMENT

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> Title of Invention

MULTI-LAYER INTEGRATED SEMICONDUCTOR STRUCTURE HAVING AN ELECTRICAL SHIELDING **PORTION**

Application Number:

10/749096

Confirmation Number:

3177

First Named Applicant:

Rafael Reif

Attorney Docket Number: MIT-136DUS Art Unit:

3745

Search string:

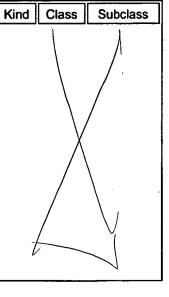
(4313126 or 4402761 or 4456888 or 4599704 or 4986861 or 5156997 or 5206186 or 5445994

or 5821138 or 5923087 or 6441478).pn.

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Note: Applicant is not required to submit a paper copy of cited US Patent Documents

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Signature

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